亞洲大學 115 學年度 第 一 學期 半導體學位學程　葉榮輝　教師在校時程表
Asia university 115academic year First semester
Semiconductor Bachelor Degree Program Rong-Hwei Yeh office hour schedule

		一 Monday	二 Tuesday	三 Wednesday	四 Thursday	五 Friday
1	08:10 | 09:00	office hour	備課及研究 prepare lessons or research	office hour	office hour	科技應用與生活 Technology Application and Life
	location	HB16R	HB16R	HB16R	HB16R	I106
2	09:10 | 10:00	office hour	備課及研究 prepare lessons or research	office hour	半導體製程與先 進封裝整合技 術 Semiconductor Process and Advanced Packaging	科技應用與生活 Technology Application and Life
	location	HB16R	HB16R	HB16R	H103	I106
3	10:10 | 11:00	office hour	備課及研究 prepare lessons or research	office hour	半導體製程與先 進封裝整合技 術 Semiconductor Process and Advanced Packaging	光電科技面面觀 Aspects of Optoelectronics Technology
	location	HB16R	HB16R	HB16R	H103	I106
4	11:10 | 12:00	office hour	備課及研究 prepare lessons or research	office hour	半導體製程與先 進封裝整合技 術 Semiconductor Process and Advanced Packaging	光電科技面面觀 Aspects of Optoelectronics Technology
	location	HB16R	HB16R	HB16R	H103	I106
N	12:10 13:00					
	location					
5	13:10 | 14:00	科技應用與生活 Technology Application and Life	office hour	微積分(一) Calculus I	IC 基礎製程與設備實務 Fundamentals of IC Processes and Equipment	備課及研究 prepare lessons or research
	location	I106	HB16R	A002	M519	HB16R
6	14:10 | 15:00	科技應用與生活 Technology Application and Life	office hour	微積分(一) Calculus I	IC 基礎製程與設備實務 Fundamentals of IC Processes and Equipment	備課及研究 prepare lessons or research
	location	I106	HB16R	A002	M519	HB16R
7	15:10 | 16:00	走讀台中・永續 之城-2 Exploring Taichung: The Sustainable City	office hour	office hour	IC 基礎製程與設備實務 Fundamentals of IC Processes and Equipment	備課及研究 prepare lessons or research
	location	L008	HB16R	HB16R	M519	HB16R
8	16:10 | 17:00	走讀台中・永續 之城-2 Exploring Taichung: The Sustainable City	office hour	office hour	備課及研究 prepare lessons or research	備課及研究 prepare lessons or research
	location	L008	HB16R	I106	HB16R	HB16R
9	17:00 18:00					
	location					
10	18:30 | 19:15					
	location					
11	19:25 | 20:10					
	location					
12	20:20 | 21:05					
	location					
13	21:15 | 20:00					
	location					

單位主管簽章：　　院長簽章：